



PATENT
0020-4666P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: KONUSHI, et al. Conf.: 1396

Appl. No.: 09/492,803 Group: 2828

Filed: January 28, 2000 Examiner: QUYEN LEUNG

For: SEMICONDUCTOR LASER DEVICE AND METHOD OF
MANUFACTURING SAME

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TECHNOLOGY CENTER 2800
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LARGE ENTITY TRANSMITTAL FORM

Assistant Commissioner for Patents
Washington, DC 20231

July 25, 2002

Sir:

Transmitted herewith is a Reply to Restriction/Election Requirement in the above-identified application.

- The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
- Petition for _____ month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.
- No fee is required.
- A check in the amount of \$0.00 is enclosed.
- Please charge Deposit Account No. 02-2448 in the amount of \$0.00. A triplicate copy of this sheet is attached.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

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